

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/714,613	KOH, HYUNG-IL	
Examiner	Art Unit	
M. Lee	2622	

	CEAD	CUED		
SEARCHED				
Class	Subclass	Date	Examiner	
348	383, 581, 563-565, 581, 588,	6/11/2006	ML	
	473-479			
	576			

INT	INTERFERENCE SEARCHED		
Class	Subclass	Date	Examiner
	-		

SEARCH NOTES (INCLUDING SEARCH STRATEGY)			
	DATE	EXMR	
EAST	6/11/20	06 ML	